



IFW

Attorney Docket no: 0553-0164.01

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
)  
Yamazaki et al. )  
)  
Serial No.: 10/651,458 )  
)  
Filed: August 29, 2003 )  
)  
For: Semiconductor Device And Method of )  
Fabricating The Same )  
)  
Examiner: Thao X. Le )  
)  
Art Unit: 2814 )

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Date: January 24, 2005

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT C

In response to the Office Action of October 29, 2004, please amend the above-identified  
application as follows:

**IN THE TITLE:**

Please replace the title with the following amended title:

~~Semiconductor~~ Display Device And Method of Fabricating The Same